German high-quality plasma spectroscopy and software solutions



STAND-ALONE SPECTROSCOPIC PLASMA MONITOR SYSTEM FOR INDUSTRIAL PRODUCTION LINES

Highlight Features:

- Up to 8 spectrometer units for data acquisition at different machine locations
- Input of up to 8 external voltage signals (e.g. from lambda probe, target voltage,...)
- Stand-alone operation by means of integrated processor unit
- Integrated touch panel display for on-site information and settings
- Communication by industrial standard interfaces (LAN, Profibus, IOs, ...)

Your Benefits:

- Upgrade your production line for increasing product quality or producing high-end products
- Stabilize process by simultaneous PID control e.g. of gas flow control and target voltage
- Control and compensate target erosion in sputter applications
- Retrofit your existing PEM for enhanced productivity
- Integrate as stand-alone system in machine control

DATA SHEET

Number of spectrometer channels I - 8

Spectral range 200 - 1100 nm (totally covered by each spectrometer)

Number of wavelength channels unlimited (selected by software without hardware modification)

Analysis of monitor tracks single, combined (+,-, /,*), ratio, average, integral

Spectral resolution 1.5 nm FWHM

Minimum time resolution | I ms

Detector CCD array with 16 Bit A/D converter

Optical fiber connector SMA 905

Analog inputs 2 (4, 8) x 0-10 volts (iCoupler)

Analog outputs 4 (8) x 0-10 volts (iCoupler)

Digital outputs 8 (16) x TTL / 24V (Opto-Coupler)

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Remote control interfaces LAN, digital inputs, (Profibus)

Processor unit Integrated MPU with EMCON SA operation system

Display 5,7" color touch panel (resistive)

Power supply 5 VDC 4A

Housing 19" rack mount box (4U, 84HP)

Dimensions [mm] 480(w) x 190(h) x 420(d)

Weight [kg] 3.5

EMICON SA Manager software on Windows® XP / 7 / 8

